

Form PTO-1449
(Rev. 8-83)U.S. Department of Commerce
Patent and Trademark Office

Atty Docket 0753-1553

Serial No. 08/698,204

INFORMATION DISCLOSURE STATEMENT

Applicants: Toshimitsu KONUMA et al.

Filing Date: August 14, 1996

Group Art Unit: 2871

FOREIGN PATENT DOCUMENTS

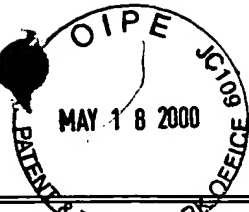
Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
V	4-133029	05/07/1992	Japan			Abst.	
J	5-203977	08/13/1993	Japan			Abst.	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner Initial	
	English translation of Japanese Patent Office Communication, dated 11/16/1999, 2 pages.

Examiner <i>Park</i>	Date Considered 7/2/00
----------------------	------------------------

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



Submitted with IDS filed 05/16/00

Sheet 1 of 1

Form PTO-1449
(Rev. 8-83)U.S. Department of Commerce
Patent and Trademark OfficeAtty.Docket No.
0756-1553Serial No.
08/698,204**INFORMATION DISCLOSURE STATEMENT**

(Use several sheets if necessary)

Applicant
Toshimitsu KONUMA et al.Filing Date
August 14, 1996Group
2871**U.S. PATENT DOCUMENTS**

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)
✓	3,600,061	08/17/71	Heilmeier et al.			
✓	4,362,771	12/07/82	Umeda et al.			
✓	4,394,067	07/19/83	Spruijt et al.			
✓	4,826,297	05/02/89	Kubo et al.			
✓	5,130,832	07/14/92	Kawaguchi et al.			
✓	5,247,375	09/93	Mochizuki et al.			
✓	5,278,685	01/11/94	Iwamoto et al.			
✓	5,436,744	07/25/95	Arledge et al.			
✓	5,442,470	08/15/95	Hashimoto			
✓	5,460,983	10/24/95	Hodges et al.			

FOREIGN PATENT DOCUMENTS

Document Number	Date	Country	Class	Subclass	Translation Yes No
1-68725	03/89	Japan			Abst.
4-78819	03/92	Japan			X
4-116623	04/92	Japan			X
6-186579	07/01/99	Japan			Abst.
6-186580	07/94	Japan			Abst.

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

Panel Assembling Technique Scriber/Cell Breaking Device: JKL-454F", 93 Latest Liquid Crystal Process Techniques, Semiconductor World, October 1, 1992, p. 272 (with English translation)
--

Examiner

Date Considered

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.